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	Application Number		10581940				
	Filing Date		2006-06-07				
INFORMATION DISCLOSURE	First Named Inventor	First Named Inventor Tetsuo Fujii					
STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Art Unit		2815				
(Not for Submission under or of K 1.55)	Examiner Name	Jerom	rome Jackson Jr.				
	Attorney Docket Numb	er	G&C 30794.108-US-WO				

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	4	2003-	174191	JP			2003-06-20						
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	1		PATHY et al., "Characterization of inductively coupled plasma etched surface of GaN using Cl2/BCl3 Chemistry:"; ac. Sci. Technol. A, Vol. 19, No. 5, Sep/Oct 2001.										
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